



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Yuji Horie, et al.  
Serial No.: 10/666,987  
Filed: September 19, 2003  
For: POLISHING CLOTH AND  
METHOD OF PRODUCING  
SAME  
Group Art Unit: 3724  
Examiner: T. V. Eley  
Attorney Docket: NMCI P045

**CERTIFICATE OF MAILING**

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**RESPONSE TO REQUIREMENT FOR RESTRICTION**

Commissioner for Patents  
Alexandria, Virginia 22313-1450

Sir:

In response to the Requirement for Restriction dated March 21, 2005 in the above-referenced application as between Group I, consisting of claims 1-7 and Group II consisting of claims 8 and 9, applicant hereby elects Group I consisting of claims 1-7 to be examined first. The election is without traverse and does not affect the inventorship.

It now goes without saying that applicant reserves the right to file a divisional application regarding Group II currently not elected.

Respectfully submitted,

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July 26, 2005  
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